

Notice of References Cited	Application/Control No. 10/803,923		Applicant(s)/Patent Under Reexamination WEN-LUNG, YU	
	Examiner Timothy M. Ayres		Art Unit 3637	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0202319	10-2003	Chen, Yun-Lung	361/683
*	B	US-2002/0185944	12-2002	Chen, Feng-Ming	312/223.2
*	C	US-5,964,513	10-1999	Korinsky et al.	312/223.2
*	D	US-6,102,501	08-2000	Chen et al.	312/223.2
*	E	US-6,209,975	04-2001	Lai, Vincent	312/223.2
*	F	US-6,234,593	05-2001	Chen et al.	312/223.2
*	G	US-6,375,287	04-2002	Lai, Vincent	312/223.2
*	H	US-6,648,429	11-2003	Chen et al.	312/223.2
*	I	US-6,671,179	12-2003	Chen, Yun-Lung	361/725
*	J	US-6,297,948	10-2001	Buican et al.	361/683
*	K	US-6,144,549	11-2000	Moss et al.	361/681
*	L	US-6,288,333	09-2001	Liu et al.	174/52.1
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.